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## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

( Not for submission under 37 CFR 1.99)

Application Number		10663402		
Filing Date		2003-09-16		
First Named Inventor	Warre	en M. Farnworth		
Art Unit		1773		
Examiner Name	V. Ch	nen		
Attorney Docket Number		2269-5595US (01-0088.00/)		

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